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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

First Named  
Inventor : Benjamin Y.H. Liu et al.

Appln. No. : 10/769,011

Filed : January 30, 2004

For : HIGH-PERFORMANCE AND MULTI-  
LIQUID-PRECURSOR  
VAPORIZATION IN  
SEMICONDUCTOR THIN FILM  
DEPOSITION

Docket No.: M419.12-0043

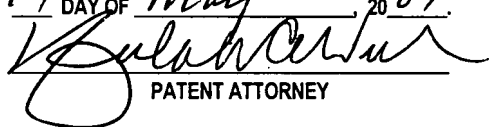
Group Art Unit: 1763

Examiner:

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

I HEREBY CERTIFY THAT THIS PAPER IS BEING  
SENT BY U.S. MAIL, FIRST CLASS, TO THE  
COMMISSIONER FOR PATENTS, P.O. BOX 1450,  
ALEXANDRIA, VA 22313-1450, THIS

14 DAY OF May 20 07.  
  
PATENT ATTORNEY

Sir:

In response to the Notice dated April 30, 2007 of a not fully responsive amendment and in full response to Official Action Mailed January 11, 2007, it is respectfully requested that the following amendments be made.

The enclosed amendment includes page 8, and is believed to fully respond. The omission of page 8 from the amendment mailed February 7, 2007 is regretted.